TRANSMITTAL FORM

Signature

Attorney Docket No.
P3P2000078US/2369NP

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In re the application of: Yuji OKUDA, et al. P E Confirmation No: 1643									
Serial No: 10/018,708				IAAL #	7 2000	Group Art Unit:	3723		
Filed: April 15, 2002				JAN 1 7 2006 Exar		Examiner: Wilso	raminer: Wilson, Lee D.		
For: Table of Wafer Polishing Apparatus Method for Polishing Semiconductor Wafer, and Method for Manufacturing Semiconductor Wafer									
ENCLOSURES (check all that apply)									
	Amen	ıdment/F	Reply	Assignment and Recordati Cover Sheet				After Allowance Communication to Group	
		After F	inal		Part B-Issue Fee Transmittal			Notice of Appeal	
	Information disclosure statement			Letter to Draftsman			Appeal Brief		
		Form 1449			Drawings			Status Letter	
		4 Reference copies			Petition			Postcard	
	Extension of Time Request *				Fee Address	Indication Form		Other Enclosure(s) (please identify below):	
	Express Abandonment				Terminal Dis	claimer			
	Certified Copy of Priority Doc				Power of Attorney and Revocation of Prior Powers				
	Response to Incomplete Appln			Change of Correspondence Address					
	Response to Missing Parts			*Extension of Term: Pursuant to 37 CFR 1.136, Applicant petitions the Commissioner to extend the time for response for xxxxxx month(s),					
	Executed Declaration by Inventor(s)			from to .					
					METHOD OF	PAYMENT			
	Chec	k no	in the amount of	\$	is enclo	sed for payment of	fees.		
	Charge \$ to Deposit Account No (Account Holder Name) for payment of fees.								
	Charge any fees or credit any overpayment to Deposit Account No. <u>02-2120</u> (Sawyer Law Group LLP)								
			SIGNAT	IDE O	E ADDI ICAN	T, ATTORNEY, OF	AGE	NT	
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Attorney Name Joseph A. Sawyer, Jr., Reg. No. 30,801									
Signature m//			4	92/1					
Date Øanuary 12, 2006									
CERTIFICATE OF TRANSMISSION/MAILING									
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop ISSUE FEE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 1/12/2006.									
Type or printed name Kym Mgóre									

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CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Mail Stop ISSUE FEE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 12, 2006.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Date: January 12, 2006

Yuji OKUDA, et al.

Confirmation No: 1643

Serial No: 10/018,708

Group Art Unit: 3723

Filed: April 15, 2002

Examiner: Wilson, Lee D.

For: TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISHING

SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING

SEMICONDUCTOR WAFER

Mail Stop ISSUE FEE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Sir:

Pursuant to 37 C.F.R. §1.97 and §1.98, Applicants submit for consideration in the above-identified application the documents listed on the attached Form PTO-1449. The Examiner is requested to make these documents of record. This Information Disclosure Statement is being submitted:

With copies.
Without copies. Copies of the documents were previously submitted in an Information Disclosure Statement and/or Office Action, directed to the related application Serial No. **, filed **. This protocol conforms with 37 C.F.R. §1.98(d) and M.P.E.P. 609 (A)(2).
This Information Disclosure Statement is being submitted with only copies of non-U.S. patent publication(s) and non-patent literature. This protocol conforms with 37 CFR 1.98(a)(2)(i), which waives the requirement for submitting a copy of each cited U.S. Patent and each U.S. patent application publication for all U.S. national patent applications filed after June 30, 2003

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□ * .	The documents listed on the attached Form PTO-1449 were cited in a Search Report directed to a counterpart international or foreign application.						
	With the application; accordingly, no fee or separate requirements are required.						
	Within three months of the application filing date, or before mailing of a first Office Action on the merits.						
	Before the mailing of a first Office action after the filing of a request for continued examination under §1.114.						
	After receipt of a first Office Action on the merits, but before the mailing date of a Final Office Action under §1.113, or a Notice of Allowance §1.311. Accompanied by one of: Certification under 37 CFR §1.97(e); or The fee set forth in §1.17(p)						
	After mailing of a final Office Action or Notice of Allowance, but on or before payment of the issue fee. Accompanied by: ☐ Certification under 37 CFR §1.97(e); and ☐ The fee set forth in §1.17(p)						
	A Certification under 37 C.F.R. §1.97(e) is provided below:						
	☐ I hereby certify that each item of information was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement. -or-						
	I hereby certify that no item of information was cited in a communication from a foreign patent office in a counterpart foreign application or, to the best of my knowledge after making a reasonable inquiry, was known to any individual designated in 37 C.F.R. §1.56(c) more than three months prior to the filing of this Information Disclosure Statement.						
Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein. If any unresolved issues remain, please contact Applicant's attorney at the telephone number indicated below.							
	Respectfully submitted,						

January 12, 2006

Date

Joseph A. Sawyer, Jr.

Attorney for Applicant(s)

Reg. No. 30,801 (650) 493-4540

FORM RTO-144	9 (Modified)	ATTY. DOCKET	ΓNO.	SERIAL N	SERIAL NO.			
LIST OF PATEN	ITS AND PUBLICA	2369NP		10/018,708	10/018,708			
APPLICANT'S II								
DISCLOSURE S		PE 4AR						
	C	APPLICANT:	APPLICANT:					
		17 2006 Y 1 MAL	Yuji OKUDA, et a	<u>al.</u>				
(Use several she	ets if necessary) igwedge	FILING DATE:		GROUP:	GROUP:			
		ATENT 8 THADESILE	April 15, 2002		3723	3723		
REFERENCE DES	SIGNATION	U.S. PA	ATENT DOCUMEN	ITS				
EXAMINER INITIALS	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPRO.)		
	5,256,599	10/26/1993	Asetta et al.					
	4,552,122	11/12/1985	Kelly					
	6,220,942	04/24/2001	Tolles et al.					
	5,454,750	10/03/1995	Cosmano et al.		·			
		FOREIGN F	PATENT DOCUME	NTS				
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLAS	Translation S		
	OTHER ART (I	ncluding Aut	hor, Title, Date, P	ertinent Pa	ges, etc.)			
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EXAMINER			DATE CONS	DATE CONSIDERED				
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.